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FEB 05 2005

Customer No.: 31561
Application No.: 10/064,703
Docket No.: 9458-US-PA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application)
Application 10/064,703)
Filed: August 8, 2002)
For: METHOD FOR DEPOSITING THIN FILM USING PLASMA)
CHEMICAL VAPOR DEPOSITION)

Applicant: Frank Lin)
Examiner: Meeks, Timothy Howard)
Art Unit 1762)

No fee is believed to be due. However, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.9458-US-PA)

Preliminary Amendment

U.S. Patent and Trademark Office
Commissioner for Patents
220 20th Street South
Customer Window, Mail Stop RCE
Crystal Plaza Two, Lobby, Room 1B03
Arlington, Virginia 22202

Dear Sir:

Prior to the examination on merits, please amend the above-identified application as follows: